## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Le

Leonard Forbes

Examiner: Joannie A. Garcia

Serial No.:

10/634,174

Group Art Unit: 2823

Filed:

August 5, 2003

Docket: 1303.102US1

A Ritle:

STRAINED SI/SIGE/SOI ISLANDS AND PROCESSES OF MAKING SAME

## **COMMUNICATION CONCERNING RELATED APPLICATION(S)**

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicant would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

Serial/Patent No. 11/210927	Filing Date/Issue Date August 24, 2005	Attorney Docket 1303.089US2	Title MICRO-MECHANICALLY STRAINED SEMICONDUCTOR FILM
11/210373	August 24, 2005	1303.094US2	STRAINED Si/SiGe STRUCTURES BY ION IMPLANTATION
11/214495	August 29, 2005	1303.098US2	SEMICONDUCTOR ON INSULATOR STRUCTURE

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted, LEONARD FORBES

By Applicant's Representatives, SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. Box 2938 Minneapolis, MN 55402

(612) 373-6960

Date 12-20-05

Marin I Dec

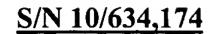
Marvin L. Beekman Reg. No. 38,377

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 20 day of December, 2005.

KACIA LEE

Signature

Name





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Joannie A. Garcia

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## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 et. seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicant respectfully requests that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicant requests that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicant with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the Supplemental Information Disclosure Statement. However, if an Office Action on the merits has been mailed, the Commissioner is hereby authorized to charge the required fees to Deposit Account No. 19-0743 in order to have this Supplemental Information Disclosure Statement considered.

Filing Date: August 05, 2003

Title: STRAINED SI/SiGe/SOI ISLANDS AND PROCESSES OF MAKING SAME

Page 2 Dkt: 1303.102US1

The Examiner is invited to contact the Applicant's Representative at the below-listed telephone number if there are any questions regarding this communication.

Pursuant to 37 C.F.R. 1.98(a)(2), Applicant believes that copies of cited U.S. Patents and Published Applications are no longer required to be provided to the Office. Notification of this change was provided in the United States Patent and Trademark Office OG Notices dated October 12, 2004. Thus, Applicant has not included copies of any US Patents or Published Applications cited with this submission. Should the Office require copies to be provided, Applicant respectfully requests that notice of such requirement be directed to Applicant's below-signed representative. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

Respectfully submitted,

LEONARD FORBES

By his Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. Box 2938
Minneapolis, MN 55402
(612) 373-6960

Date 12-20-05

By

Marvin L. Beekman

Reg. No. 38,377

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 20 day of December, 2005.

FACIA LEE

Signature Lee

PTO/SB/08A(10-01)

Approved for use through 10/31/2002, OMB 651-0031

US Patent & Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO INFORMATION DISCLOSURE	
STATEMENT BY APPLICANT	
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<b>Application Number</b>	10/634,174
Filing Date	August 5, 2003
First Named Inventor	Forbes, Leonard
Group Art Unit	2823
Examiner Name	Garcia, Joannie

US PAT	ENT DOCUMENTS	
Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropria
11/10/2005	Forbes, L., et al.	06/27/2005
04/27/1976	Dennison, R. T., et al.	04/10/1975

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
	US-2005/0250274-A1	11/10/2005	Forbes, L. , et al.	06/27/2005
	US-3,953,839	04/27/1976	Dennison, R. T., et al.	04/10/1975
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Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	T²	

OTHER DOCUMENTS NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²